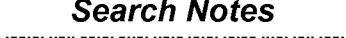


Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/519,838	MITRANI ET AL.
	Examiner	Art Unit
	Taeyoon Kim	1651

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner